


U.S. PTO
10/02/992
12/19/01

JC 844

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

AFPL NUM 10027992	FILING DATE 12/19/2001	CLASS 148	SUBCLASS 554	GAU 1742	EXAMINER  Kastler
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*APPLICANTS: Kardokus Janine; Wu Chi; Parfeniuk Christopher; Bushler Jane;

*CONTINUING DATA VERIFIED:


THIS APPLICATION IS A DIV OF 09/74,714 11/15/2000 -17C
WHICH IS A CON OF 09/615,474 07/13/2000 PAT 6,331,234
WHICH IS A CON OF 09/324,299 02/02/1999 PAT 6,113,761

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*FOREIGN APPLICATIONS VERIFIED:

None

DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 115 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	JM34006D1V
Verified and Acknowledged Examiners's initials 	
TITLE: Methods of forming copper-containing sputtering targets	

U.S. DEPT. OF COMMERCE PAT. & TM. PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
Assistant Examiner		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawn	Figs. Drawn
Primary Examiner		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
PREPARED FOR ISSUE		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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